



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#8

4/17/03
vs

Application Serial No. 09/755,673
Filing Date 1/5/2001
Inventor Forbes et al.
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner Nguyen, K.D.
Attorney's Docket No. MI22-1531
Title: Methods of Forming Capacitor Structures, and Capacitor Structures

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: 4/3/03

By: [Signature]

Robert C. Hyta
Reg. No. 46,791

04/10/2003 ZJUHR1 00000036 09755673

01 FC:1806

180.00 OP

RECEIVED
APR 11 2003
TC 2800 MAIL ROOM

EV085429671